

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Tikashi AKATSU *et al.*

Application No:

Group Art Unit:

Filing Date: Concurrently herewith

Examiner:

For: WAFER WITH A RELAXED USEFUL
LAYER AND METHOD OF FORMING THE
WAFER

Attorney Docket No.: 4717-8900

INFORMATION DISCLOSURE STATEMENT

MS PATENT APPLICATION

Commissioner for Patents

P.O. Box 1450

Arlaxandria, Virginia 22313-1450

Sir:

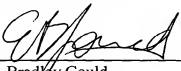
Pursuant to Applicant's duty of disclosure under 37 C.F.R. § 1.56, enclosed are copies of Nine (9) references listed on the enclosed Form PTO-1449 for the Examiner's review. Also enclosed is a copy of the International Search Report from the corresponding foreign application on which the references were cited.

It is respectfully requested that the references be made of record in this application by the Examiner's completion and return of the attached Form PTO-1449.

No fee is believed to be due for the submission of the references. Should any fees be required, however, please charge such fees to Winston & Strawn Deposit Account No. 50-1814. A copy of this sheet is enclosed for accounting purposes.

Respectfully submitted,

Sept. 17, 2003
Date


E. Bradley Gould (Reg. No. 41,792)
For: Alan A. Fanucci (Reg. No. 30,256)

WINSTON & STRAWN
Customer No. 28765

202-371-5771

